

PCD

Polycrystalline Diamond



IPOL

ILJIN Polycrystalline Diamond

	Grade	Grain Size	Property
Coarse	CXLII	40µm	Specially designed for superior wear resistance, bi-modal structure
	CXL	25µm	Excellent wear resistance with strong diamond bonding. General purposes for high Si% Al alloy composite, bi-modal structure
	CCW	25µm	Good wear resistance with special binder and diamond bonding
Medium	СМ	10µm	General purposes for Al and Al-Si alloy
	CMW	10µm	General purpose, easy wire cutting and good impact resistance
Fine	CFW	4µm	Good surface finishing
	CUFSII	2µm	Good surface finishing
	XUFII	< 1µm	Excellent impact resistance and easier tool fabrication
	UFD-M	<1µm	Ultra fine diamond for high performance for Al-alloy milling application

75pi diameter disc available in CM, CMW, CXL

